

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0

Title of Invention	METHOD OF FORMING STRAINED SILICON MATERIALS WITH IMPROVED THERMAL CONDUCTIVITY						
Application Number:	10/710,826						
Confirmation Number:	85104						
First Named Applicant:	Stephen Bedell						
Attorney Docket Number:	FIS920040069						
Art Unit:	2813						
Examiner:	Heather Doty						
Search string:	(20040004271).pn						
US Published Applications							
Note: Applicant is not required to submit a paper copy of cited US Published Applications							
init	Cite.No.	Pub. No.	Date	Applicant	Kind	Class	Subclass
HD	1	20040004271	2004-01-08	Fukuda et al.			
Signature							
Examiner Name				Date			
Heather Doty				10/21/05			